

**SUPPLEMENTAL FORM PTO-1449 TO BE FILED WITH
INFORMATION DISCLOSURE STATEMENT**



U.S. Department of Commerce
Patent and Trademark Office

Atty. Docket No. OSU1159-141 Serial No. 09/755,437

**INFORMATION
DISCLOSURE STATEMENT
BY APPLICANTS**

Richard L. McCreery

Applicant

January 5, 2001

Filing Date

Group Art Unit

Examiner's name

U.S. PATENT DOCUMENTS

Examiner's Initial	Document Number	Date	Name	Class/Sub-class
	NONE			

FOREIGN PATENT DOCUMENTS

Examiner's Initial	Document Number	Date	Country/Name	Translation? yes/no
	NONE			

OTHER DOCUMENTS

- REF* 1. C. Joachim, J.K. Gimzewski, R.R. Schlittler, C. Chavy, "Electronic Transparency of a Single C₆₀ Molecule", Phys. Rev. Lett., 74(11), 2102-2105. 3-1995
- REF* 2. P. Allongue, M. Delamar, B. Desbat, O. Fagebaume, R. Hitmi, J. Pinson, J.M. Saveant, "Covalent Modification of Carbon Surfaces by Aryl Radicals Generated from the Electrochemical Reduction of Diazonium Salts", J. Am. Chem. Soc., 1997, 119, 201-207.
- REF* 3. C. P. Andrieux, F. Gonzales, J.M. Saveant, "Derivatization of Carbon Surfaces by Anodic

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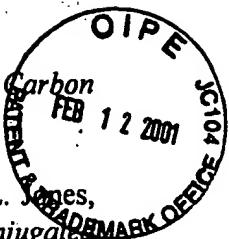
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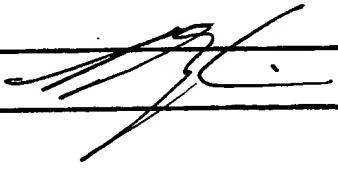
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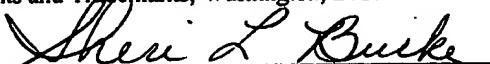
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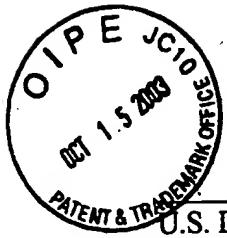
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CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8 (A)

Date of Deposit: February 6, 2001

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Sheri L. Burke



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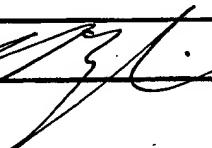
Examiner's Initial	Document Number	Date	Name	Class/Sub-class
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REF	5,846,909	12/08/1998	McDevitt et al.	505/233
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	NONE			

OTHER DOCUMENTS

None.

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